

Electronic Acknowledgement Receipt

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Application Number:	10681509
International Application Number:	
Confirmation Number:	9643
Title of Invention:	METHOD OF UNIFORM SEEDING TO CONTROL GRAIN AND DEFECT DENSITY OF CRYSTALLIZED SILICON FOR USE IN SUB-MICRON THIN FILM TRANSISTORS
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Request for Certificate of Correction	1135-certificate_of_correction.pdf	70084 913a89dce810bad94ac60735a4751ee bf7e01237	no	2

Warnings:

Information:					
2	Request for Certificate of Correction	1135-SB44.pdf	130631	no	2
			3137cad1257cdd698b67da877125e3e45cc7b1c9		
Warnings:					
Information:					
Total Files Size (in bytes):			200715		
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